

Correction to “A Two-Stage Deep Learning Method for Robust Shape Reconstruction With Electrical Impedance Tomography”

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IN [1], (9) contained a typographical error. It should be as follows:

The $\text{diag}(1-u \odot u)$ should be $\text{diag}(1-g \odot g)$. (9)

REFERENCES

- [1] S. Ren, K. Sun, C. Tan, and F. Dong, “A two-stage deep learning method for robust shape reconstruction with electrical impedance tomography,” *IEEE Trans. Instrum. Meas.*, vol. 69, no. 7, pp. 4887–4897, Jul. 2020, doi: [10.1109/TIM.2019.2954722](https://doi.org/10.1109/TIM.2019.2954722).

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